



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Gu-Sung KIM

Art Unit: 2814

Serial No. 10/073,173

Examiner: Long Pham

Filed: February 13, 2002

*Confirmation No. 4677*

For: WAFER LEVEL PACKAGE WITH AIR PADS  
AND MANUFACTURING METHOD THEREOF

Attorney Docket No. 259/014

**PRELIMINARY AMENDMENT**

Mail Stop Amendments  
Commissioner for Patents  
United States Patent and Trademark Office  
P.O. Box 1450  
Alexandria, Va. 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

In connection with the Request for Continued Examination filed concurrently herewith and in response to the Office action mailed March 30, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

**AMENDMENTS TO THE CLAIMS** are reflected in a listing of claims that begins on page 2 of this paper.

**REMARKS/ARGUMENTS** begin on page 5 of this paper.